THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date

In re the Application of

Masaaki KURIHARA et al.

Group Art Unit: 1756

Application No.: 10/614,345

Examiner:

J. RUGGLES

Filed:

July 8, 2003

Docket No.: 123770

For:

PHASE MASK FOR FORMING DIFFRACTION GRATING, METHOD OF FABRICATING

PHASE MASK AND METHOD OF FORMING DIFFRACTION GRATING

LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION OF TIME UNDER 37 C.F.R. §1.136(a) AND TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired August 30, 2006, an extension of time for a period of 2 months is hereby requested. We previously paid for a one month extension of time in the amount of \$120. Attached hereto is our Check No. 185509 in the amount of \$330 in payment for:

	Extension fee for response within first month pursuant to §1.136(a) (\$120.00)
X	Extension fee for response within second month pursuant to §1.136(a) (\$450.00)
	Extension fee for response within third or subsequent month pursuant to §1.136(a) (\$1020.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

gistration No. 27,075

Joel S. Armst 665 2006 SZEWDIE1 00000051 10614345

Registration Nor 362430

330.00 OP

JAO:JSA/ldg

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400

**DEPOSIT ACCOUNT USE** AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461